

Aqueous Processable Dry Film Photoresist

ALPHO NIT250

(FOR PLATING AND ETCHING APPLICATIONS)

Nichigo—Morton Co., LTD.

CONDITION/CHARACTERISTICS

| PROCESS | PROCESSING CONDITION | CHARACTERISTICS |
|------------|---|--|
| LAMINATION | Preheating : 50 ~ 60 °C Temperature : 100 ~ 120 °C Pressure : 2 ~ 4 kg/cm ² Speed : 1.0 ~ 2.5 m/min | Resist thickness : 50 μm (Polyester carrier : 16 μm) film thickness |
| | ☆It is necessary to leave the panel for at least 15minutes after lamination. | |
| EXPOSURE | HV or UHV mercury lamp Exposure Energy : 80 ~120 mJ/cm ² ☆It is necessary to leave the panel for at least 15minutes after Exposure. | Sensitivity : Resist 6 ~ 7 ※1) Resolution : 30 μm Adhesion of fine line : 30 μm (After Development) |
| DEVELOPING | Solution : 0.7 ~ 1.0%Na ₂ CO ₃ aq. Temperature : 28 ~ 30 °C Spray pressure : 1.5 ~ 2.0 kg/cm ² | Developing time : 45~70 sec ※2) |
| ETCHING | Condition : CuCl ₂ /2.5N-HCl 45~50 °C FeCl ₃ /2.5N-HCl 40 °C Time : 60 ~ 150 sec | Etching time depends on the thickness of copper foil. |
| STRIPPING | Solution : 2 ~ 3%NaOHaq. Temperature : 40 ~ 50°C Spray pressure : 1.5 ~ 2.5 kg/cm ² | Stripping time : 3 ~ 5 min. ※2) |

※1)Sensitivity : Stouffer 21 step sensitivity Guide

※2)Developing and Stripping time : Break point 2/3 (~1/2)

TECHNICAL DATA

FOR ALPHO NIT250

1. SENSITIVITY

| | | | |
|--------------------------------------|----|-----|-----|
| Exposure Energy(mJ/cm ²) | 80 | 120 | 160 |
| Sensitivity (step) | 6 | 7 | 8 |

1) Developing condition : 1%Na₂CO₃aq., 30°C, Spray pressure 1.5kg/cm², 50sec.

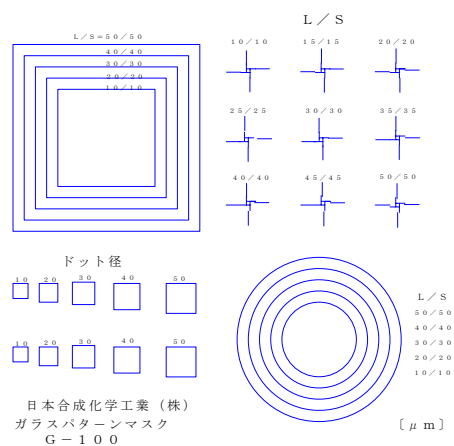
2) Sensitivity : Stouffer 21 step sensitivity Guide

2. RESOLUTION

| | | | |
|---------------------------------------|----|-----|-----|
| Exposure Energy (mJ/cm ²) | 80 | 120 | 160 |
| Sensitivity (step) | 6 | 7 | 8 |
| Resolution (μm) | 30 | 35 | 35 |

1) Pattern mask : ALPHO Glass Pattern Mask G-100

2) Developing Condition : 1%Na₂CO₃aq., 30°C, Spray pressure 1.5kg/cm², 50sec. (Break point 2/3)



ALPHO Glass Pattern Mask G-100

3. ADHESION OF FINE LINE

| Exposure Energy (mJ/cm ²) | Sensitivity (step) | Adhesion of fine line (μ m) |
|---------------------------------------|--------------------|----------------------------------|
| 8 0 | 6 | 3 0 |
| 1 2 0 | 7 | 3 0 |
| 1 6 0 | 8 | 2 5 |

1) Pattern mask : ALPHO Glass Pattern Mask G-100

2) Developing Condition : 1%Na₂CO₃aq., 30°C, Spray pressure 1.5kg/cm², 70sec. (Break point 1/2)

4. FLEXIBILITY

1) Evaluation : Laminated on copper and Capton sides (polyimide)of FPC board

Exposure Energy : 80mJ/cm² on the whole surface

180° Bend

2) Result : No crack on both sides

5. CONTRAST(COLOUR DIFFERENCE)

ΔE : 25 (Hold time : 15minutes after exposure)

(Exposure Energy : 80mJ/cm²)

6. STRIPPING

| | | | |
|------------------------|---------|-------|-------|
| NaOH (wt%) | 2 . 5 % | 3 % | 4 % |
| Stripping TIME (sec.) | 1 2 3 | 9 7 | 8 7 |
| Stripped Particle size | Midium | Sheet | Sheet |

1) Test piece : 10 × 20 cm Substrate, Exposed on the whole surface

(Exposure Energy : 80mJ/cm²)

2) Stripping Condition : 50°C, Spray pressure 1.5kg/cm²